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Patent  
Attorney's Docket No. 015290-238

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

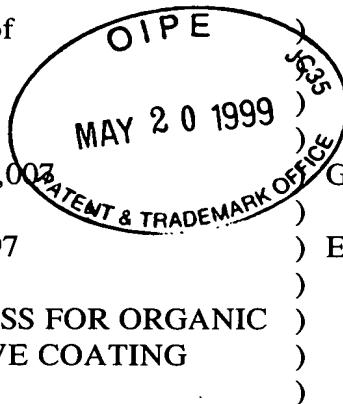
In re Patent Application of

Jeffrey HUNG et al.

Application No.: 09/002,003 ) Group Art Unit: 1765

Filed: December 31, 1997 ) Examiner: L. VINH

For: ETCHING PROCESS FOR ORGANIC )  
ANTI-REFLECTIVE COATING )



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**INFORMATION DISCLOSURE STATEMENT**

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. §1.56,  
Applicants hereby submit the following information which was cited in an International  
Search Report (copy enclosed) issued in a corresponding PCT application  
(PCT/US98/26226) mailed on April 22, 1999. Pursuant to 37 C.F.R. § 1.98, a copy of  
each of the documents cited is enclosed.

European Patent Publication No. 0 407 169, January 9, 1991;  
PCT Patent Publication No. WO97/07145, February 27, 1997; and  
"Dry Etching of Bottom Anti-Reflective-Coat and its Application to Gate Length  
Control", A. Nishizawa, et al., IEEE International Symposium on Semiconductor  
Manufacturing Conference Proceedings, XP-002099210, October 6-8, 1997,  
pages F13-F16.

Information Disclosure Statement  
Application No. 09/002,007  
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I, the undersigned, hereby certify that each item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.

To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner initialled copy of this form be returned to the undersigned.

Respectfully submitted,

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Date: May 19, 1999